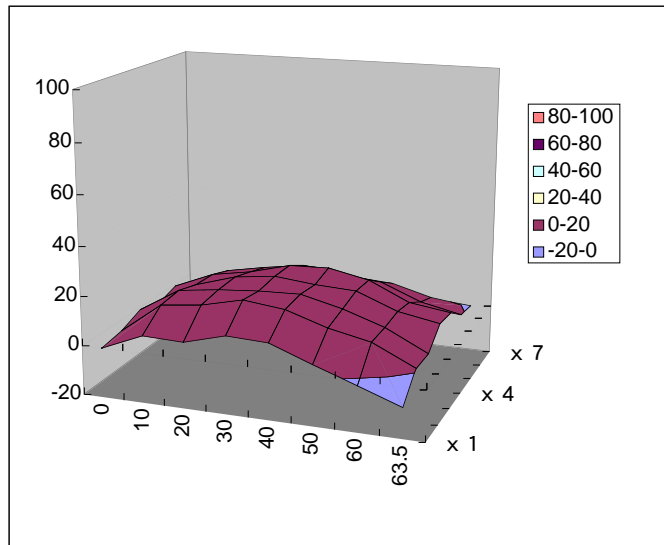
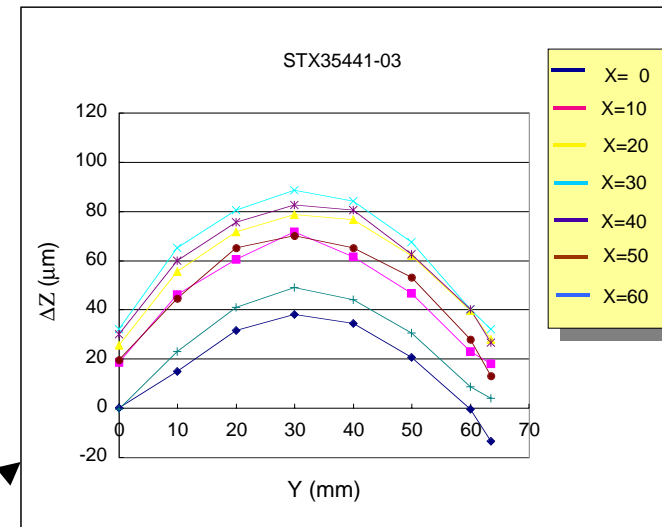
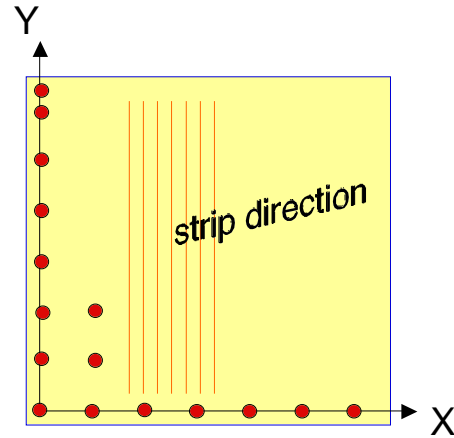


Planarity of Hamamatsu Sensors

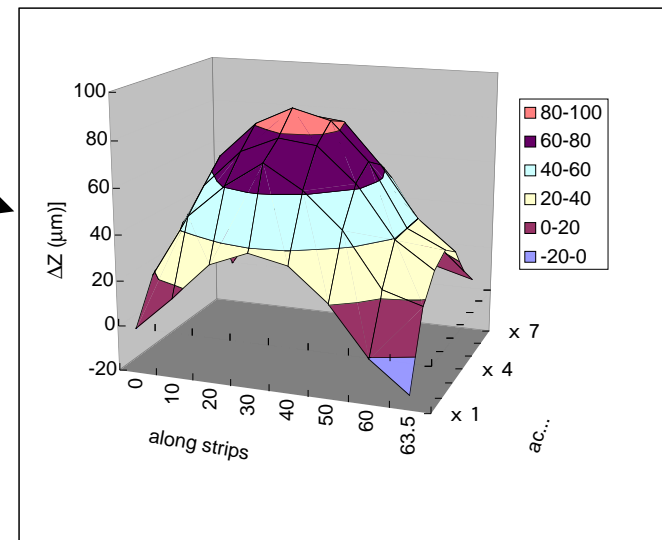
method: microscope focusing

precision: ca. $\pm 3 \mu\text{m}$
 points: every 10 mm

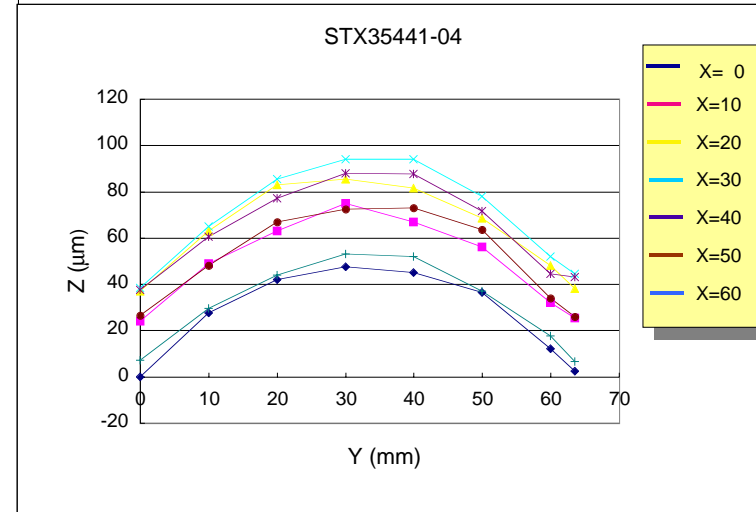
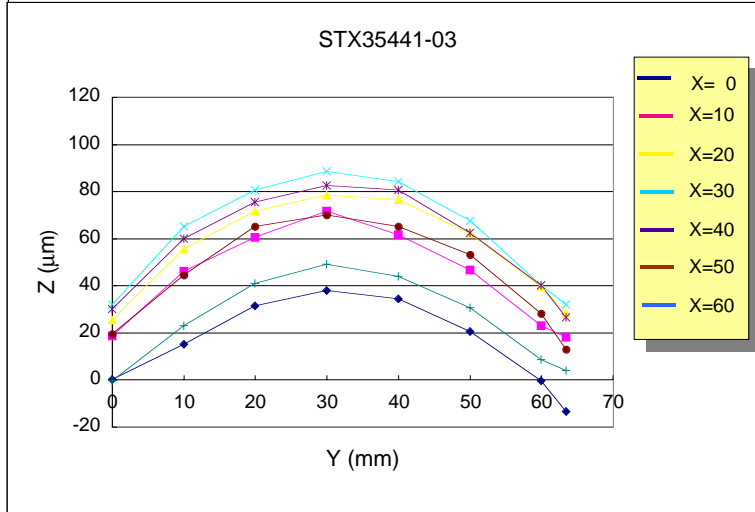
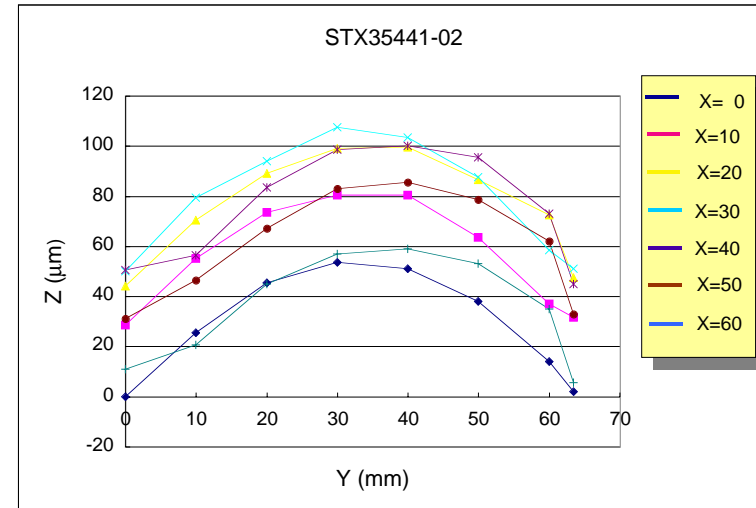
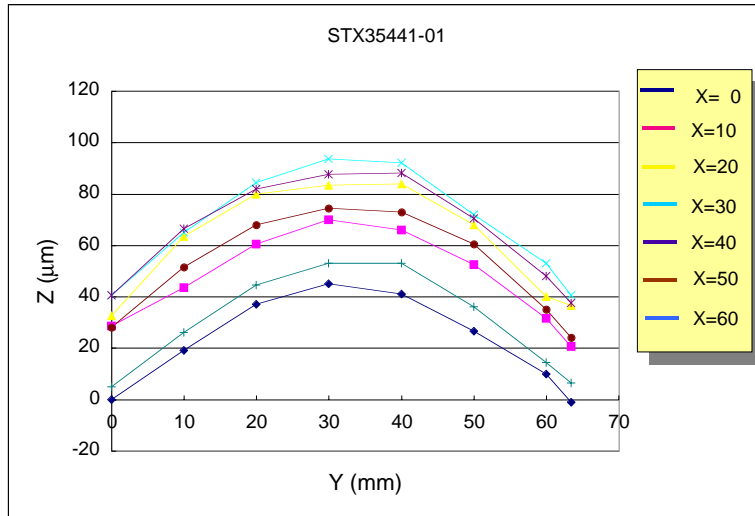


Typical p-on-n
 (single-side process)

Typical n-on-n
 (double-side process)



Planarity of 8 p-on-n Sensors Used for Module Assembly



Planarity of 8 p-on-n Sensors Used for Module Assembly (cont'd)

